

Notice of References Cited

Application/Control No.

10/081,945

Applicant(s)/Patent Under
Reexamination
BAILIE, BRIAN D.

Examiner

Joseph P. Hirl

Art Unit

2121

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Shifu Chen et al, A New Generation of Intelligent Punching Environment for Computerized Embroidery, 1994, IEEE, 1063-6730/94, 692-695
	V	S. Amin-Nejad et al, TMS320C40 Parallel Processor for High Speed Imaging Application, 1999, IEE, Image Processing and Its Applications, Conference Publication No 465, 429434
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